



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 6163

Toshikazu TACHIKAWA et al.

Docket No. 2002\_0069

Serial No. 10/053,622

Group Art Unit 1752

Filed January 24, 2002

Examiner Rosemary E. Ashton

NEGATIVE-WORKING PHOTORESIST COMPOSITION

## LETTER RE: INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In connection with the Notice of Allowance dated January 23, 2004, where it was stated that the IDS of November 22, 2003 (should be November 22, 2002) was filed without a PTO-1449, submitted herewith is a copy of such PTO-1449 with a stamped postcard receipt as proof of filing. Acknowledgment by initialing the references cited is respectfully requested.

Respectfully submitted,

Toshikazu TACHIKAWA et al.

TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT BY:

Manhundary

Matthew M. Jacob Registration No. 25,154 Attorney for Applicants

MJ/tg Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 January 29, 2004

Sheet 1 of 1				***	•		;			
FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE				ATTY D CKET NO.  2002_0069  SERIAL NO.  10/053,622 JAN 2 9 2004					E 865	
PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)				APPLICANT Toshikazu TACHIKAWA et al.						
(Use several sheets if necessary)  Date Submitted to PTO: November 22, 2002				FILING DATE January 24, 2002			1	GROUP 1752		
				U.S. PATENT DO						
*EXAMINER INITIAL		DOCUMENT	DATE		ME	CLASS	SI	JBCLASS	FILING DATE IF APPROPRIATE	
	AA	5,700,625	12/1997	Sato	et al.					
•	AB	6,319,853	11/2001	Ishibasi	ni et al.					
	AC								<u>.</u>	
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FOREIGN PATENT DOCUMENTS										
		DOCUMENT NUMBER	DATE	cour	NTRY	CLASS		JBCLASS	TRANSLATION YES NO	
	AJ	198722	3/1999	K	R					
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)										
	AO		•							
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EXAMINER				DATE CONSIDERED .						

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



ATTY DOCKET #: 2002\_0069

Due Date: None

Confirmation No. 6163

**OUR REF:** 

2002\_0069/MJ/00774

Applicant:

Toshikazu TACHIKAWA et al.

Serial No.:

10/053,622

Filing Date: January 24, 2002

Title: NEGATIVE-WORKING PHOTORESIST COMPOSITION

## Receipt of the following papers is acknowledged:

Supplemental Information Disclosure Statement PTO-1449 w/4 references



Date: November 22, 2002

Attorney: MJ/jmj

[Check No.\_\_\_\_